

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814 Examiner: MAI, ANH D

In re PATENT APPLICATION of: : Hiroki NAKAMURA Applicants : 09/625,178 Appl.. No. INFORMATION Filed : July 25, 2000 **DISCLOSURE** STATEMENT : SEMICONDUCTOR DEVICE For HAVING WIRING PATTERNS AND DUMMY PATTERNS COVERED WITH INSULATING LAYER Attorney Ref.: F98ED0762 September 8, 2003 THRIOLOGY CENTER 21 Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir:

This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. § 1.97(c)(1).

Attached are copies of (1) one Office Action from Japanese Patent and Trademark Office and its English translation, (2) two Japanese laid open patent publications and their English translations, (3) one US patent publication, which is a counterpart of one Japanese laid open patent publication mentioned above. The publications are listed on the attached Form PTO-1449.

Each item of information contained in the information disclosure statement was first cited in any communication form Japanese patent Office in a counterpart Japanese application not more than three months prior to the filing of this information disclosure statement. Since this Information Disclosure Statement is being filed based on 37 C.F.R. § 1.97(c)(1) with a above-mentioned statement specified paragraph (e)(1), no fee is required, and the requirements of 37 C.F.R. §§ 1.97 and 1.98 are deemed to be fully met as to all documents submitted. Consideration of the submitted documents is respectfully requested.

Respectfully submitted,

Junichi Mimura (Reg. No. 40,351)

Oki America, Inc.

1101 14th Street, N.W., Suite 555

Washington, D.C. 20005

Telephone:

(202) 452-6190

Telefax:

(202) 452-6148

Customer No.: 26,071

September 8, 2003

Examiner

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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				Atty Docket F98ED0762	U.S. Application No.: 09/625,178		
				Applicant Hiroki Nakamura			
				U.S. Filing Date July 25, 2000	Group 2814		
	-		U.S. PAT	ENT DOCUMENTS	1		
Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date
	AA	5,808,363	09/15/98	Watanabe	257	758	11/14/96
	AB						
	AC						
	AD				•		
	AE						
	AF						
	AG						
	АН						
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			FOREIGN F	PATENT DOCUMENTS	_		
		Document Number	Date	Country	Class	Sub- Class	Translation
	AL	Japanese Laid open vatent 07-161706	6/23/95	JAPAN	H01L	21/316 	Full translation
	AM	Japanese Laid open √ patent 09-139431	5/27/97	JAPAN	H01L	21/82 SA	Fully translation
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Examiner					Date Considered		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.